

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application for:

Kevin J. Lee

Serial No. 10/808,763

Filed: March 24, 2004

For: CONTROLLED POTENTIAL ANODIC
ETCHING PROCESS FOR THE
SELECTIVE REMOVAL OF
CONDUCTIVE THIN FILMS

Examiner: Lois L. Zheng

Art Unit: 1742

AMENDMENT AND RESPONSE TO OFFICE ACTION

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Dear Ma'am:

In response to the Office Action dated January 16, 2007, please amend the above-captioned application as set forth below.

Amendments to the Drawings are reflected on page 2 of this response.

Amendments to the Claims are reflected in the listing of claims and begins on page 3 of this response.

Remarks/Arguments begin on page 4 of this response.